

Characteristics of fast ion profile with MHD activities and improvement of fast ion confinement with AE suppression by counter-ECCD in LHD

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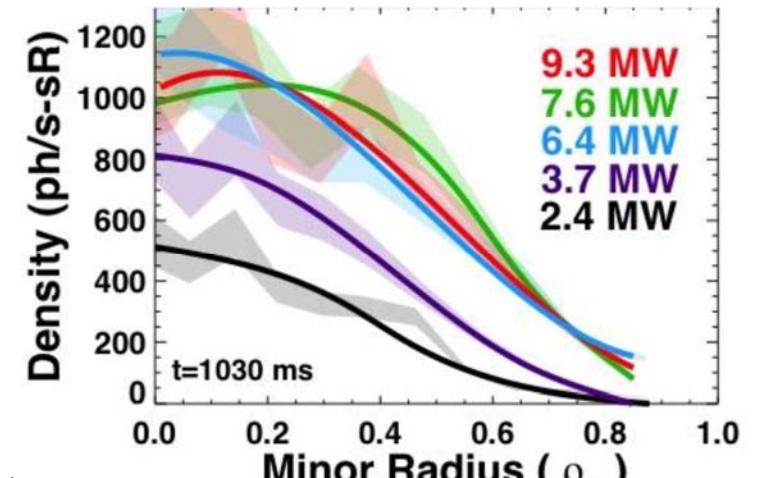
Contents

- Introduction
 - ✓ Background and motivation
 - ✓ D-D experiments in LHD
- Experimental Results
 - ✓ Control of beam deposition profile
 - ✓ EP profile with AEs
 - ✓ AE control with ECH or ECCD
- Summary

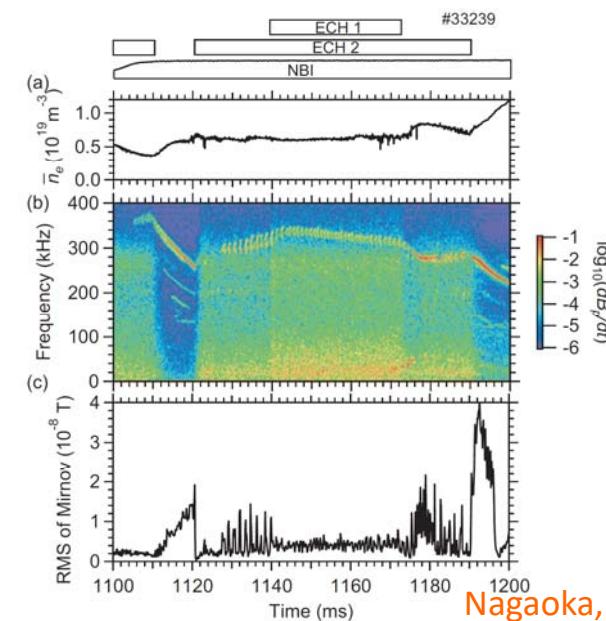
Background and Motivation

Precise prediction of EP profile in fusion burning plasmas is an important subject;

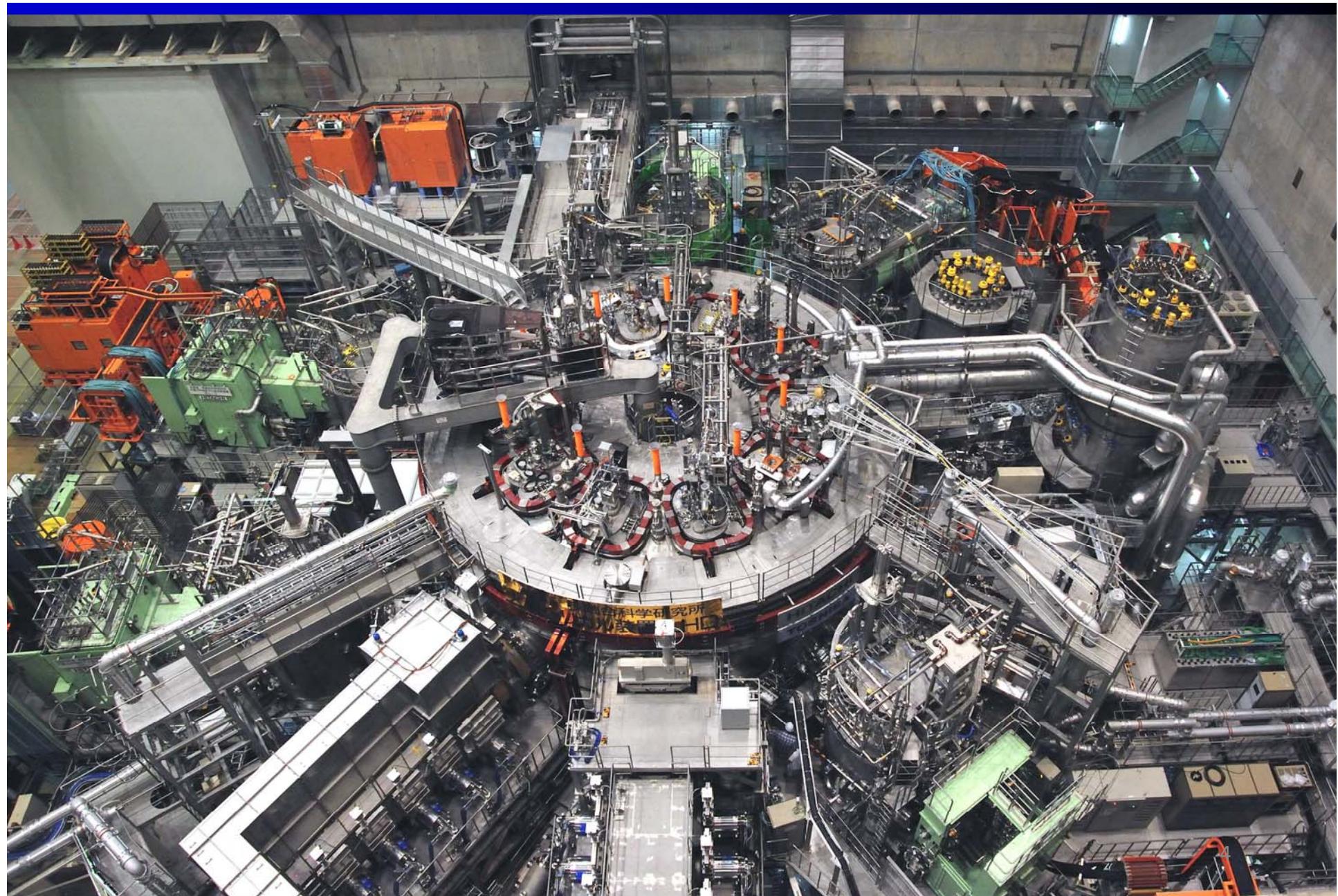
- Modeling of EP transport and EP profile with AE activities
 - kick model
 - critical gradient model/EP profile stiffness
- External control knob for EP confinement
 - RMP
 - pellet
 - ECH/ECCD



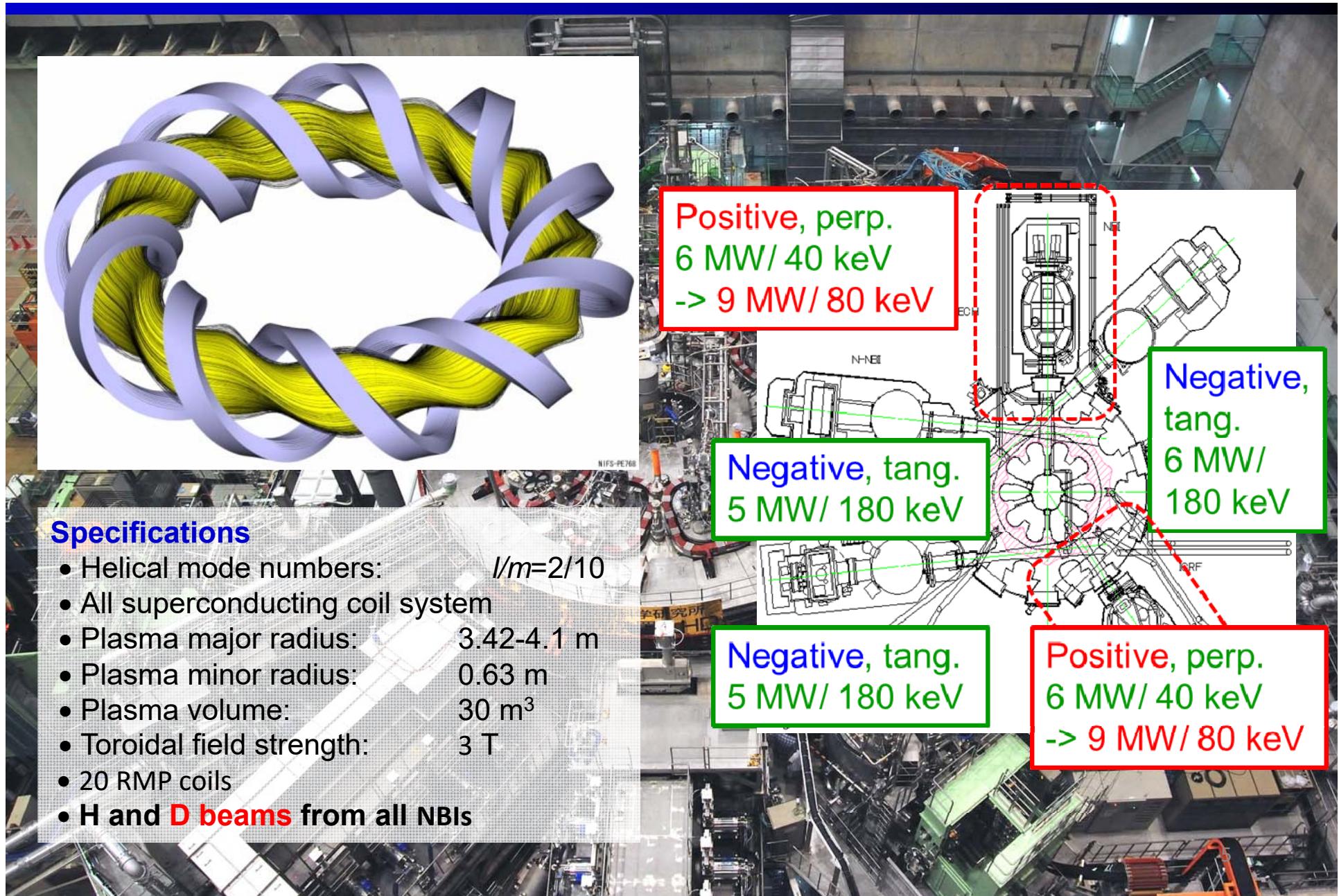
Collins, PRL 2016



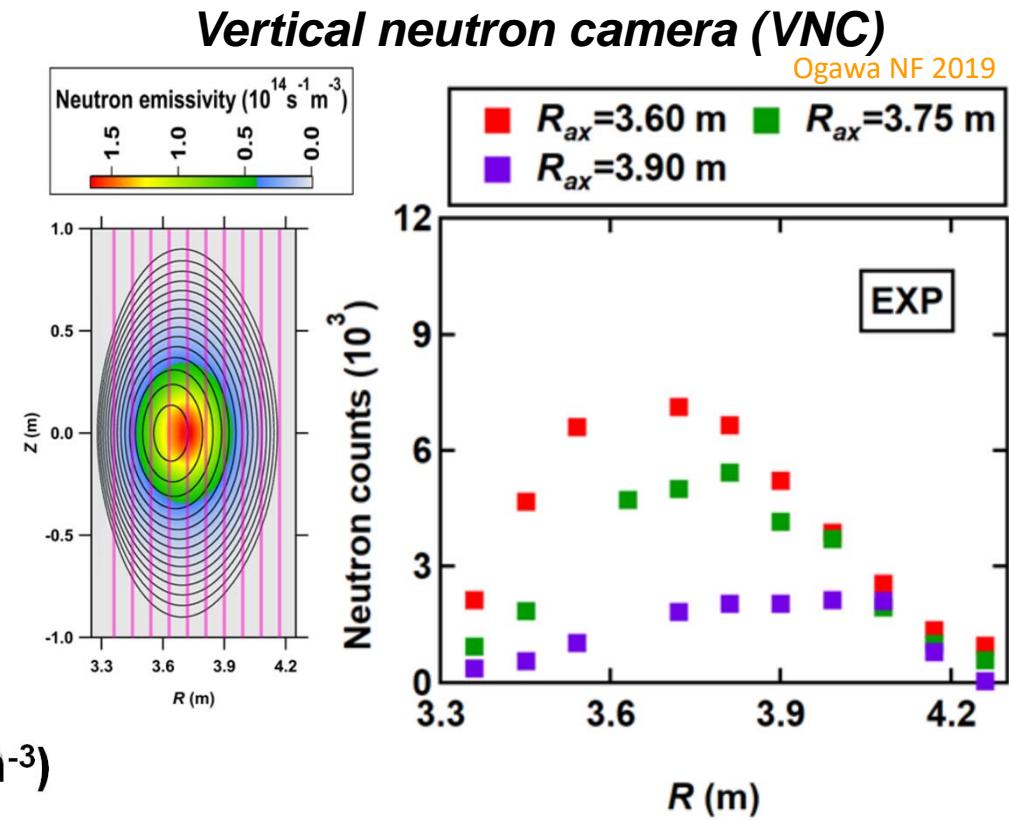
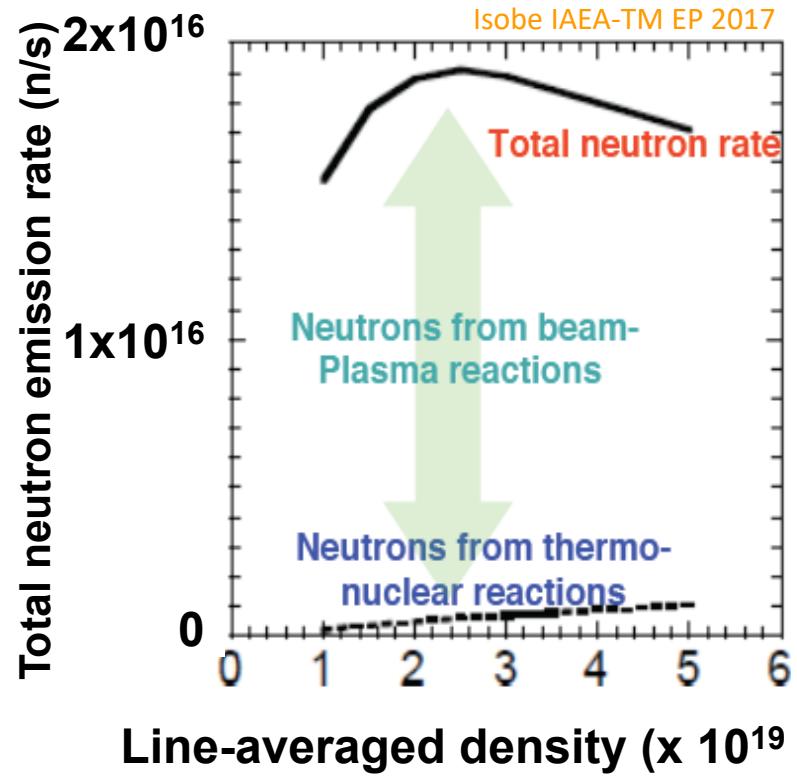
Large Helical Device (LHD)



D-D experiment since 2017



Neutron Emission is dominated by beam-plasma interaction

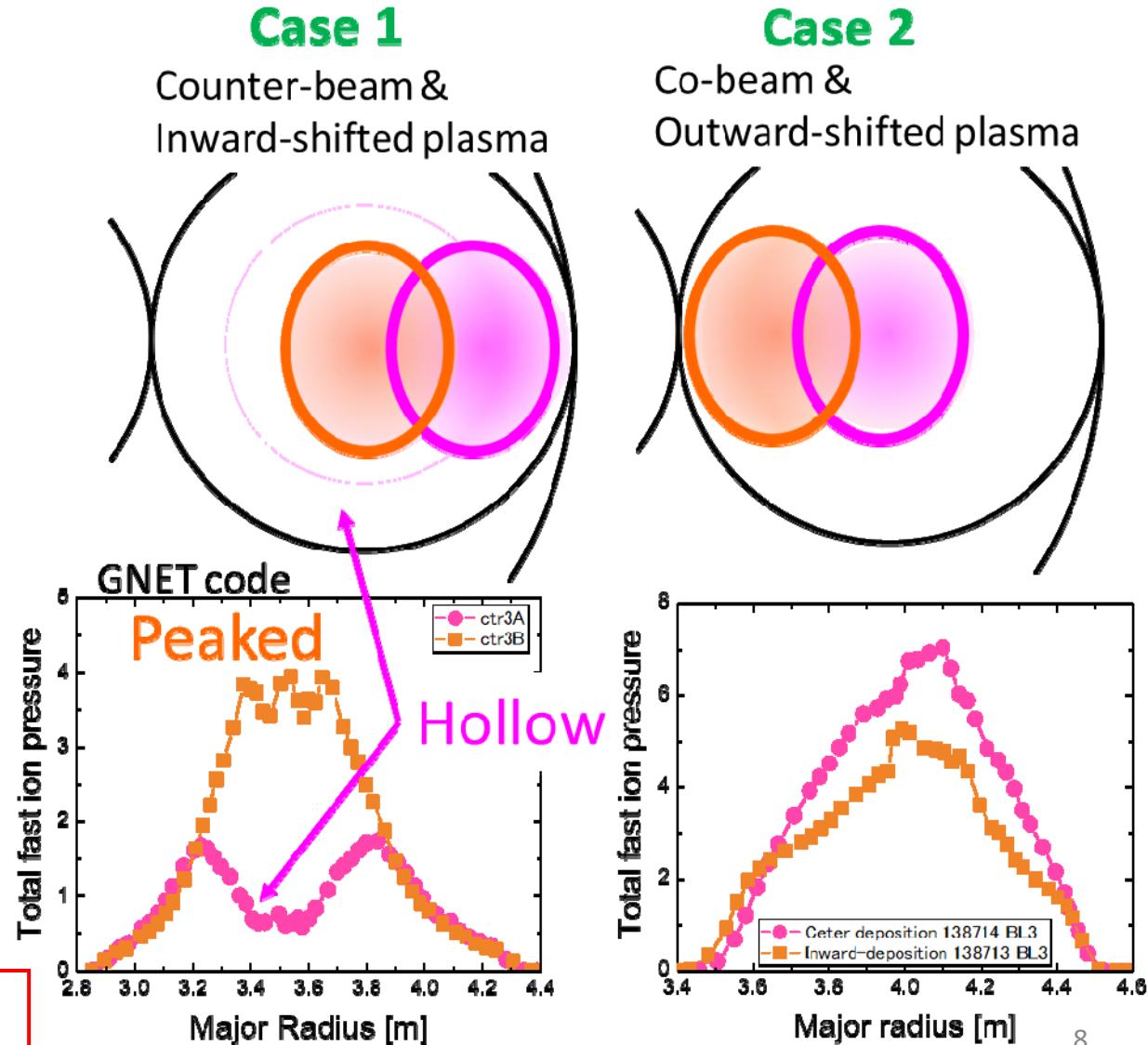
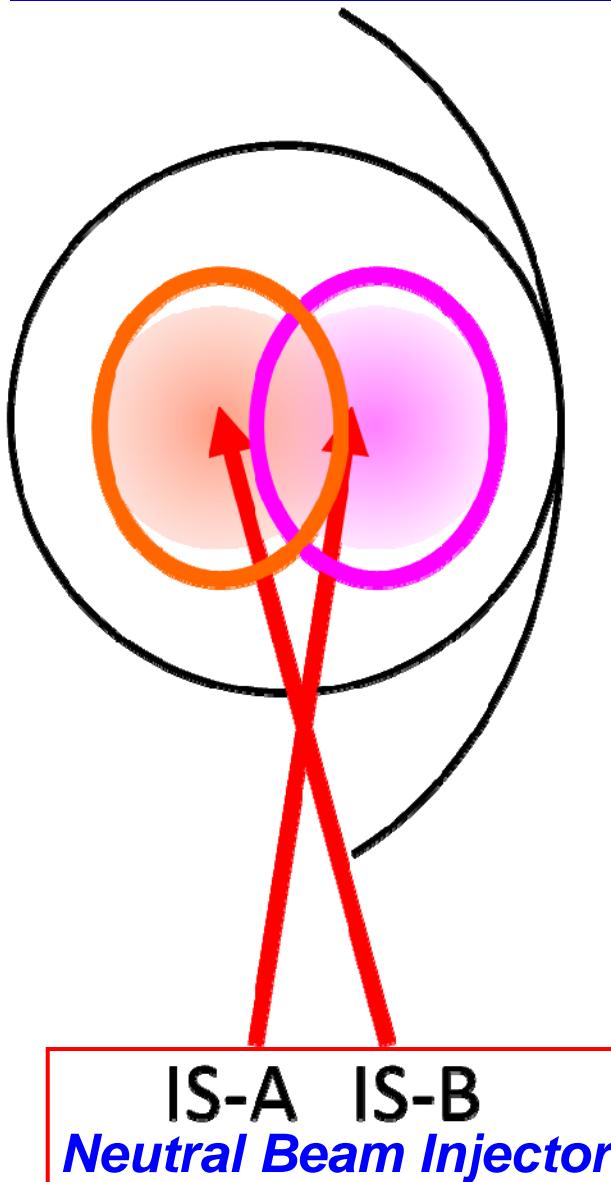


- Beam-Plasma interaction dominates the neutron emission
=> Neutron emission corresponds to EP density
- Vertical Neutron Camera reveals EP density profile

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Beam deposition profile can be controlled with combination of IS operation and plasma position



Demonstration of beam deposition control

Magnetic field dependence

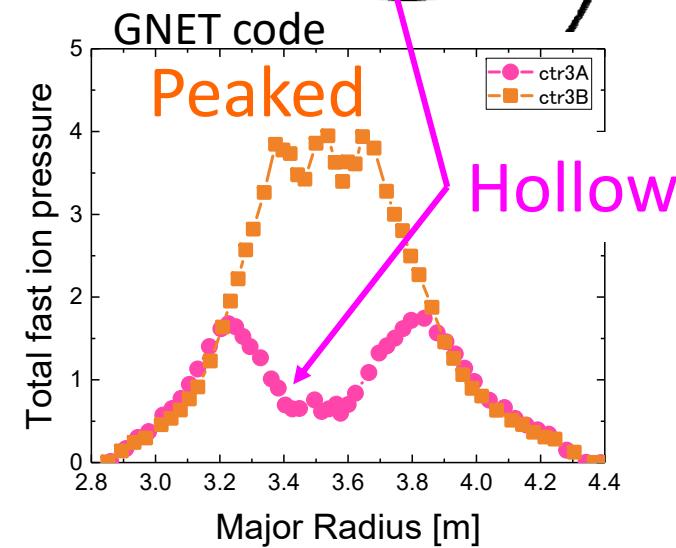
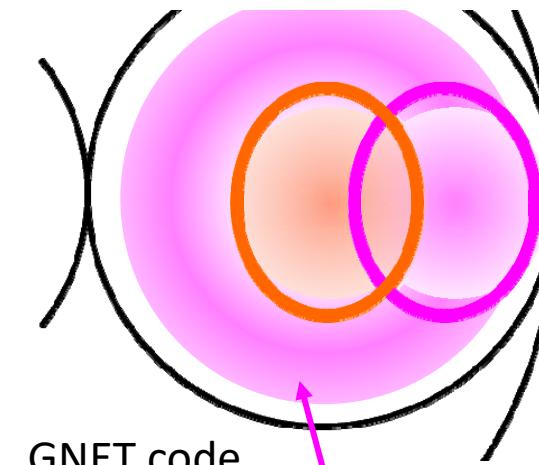
High B ($B_{Ax}=-2.75T$)

Low beam beta ($\beta_{beam} \sim 0.1\%$)

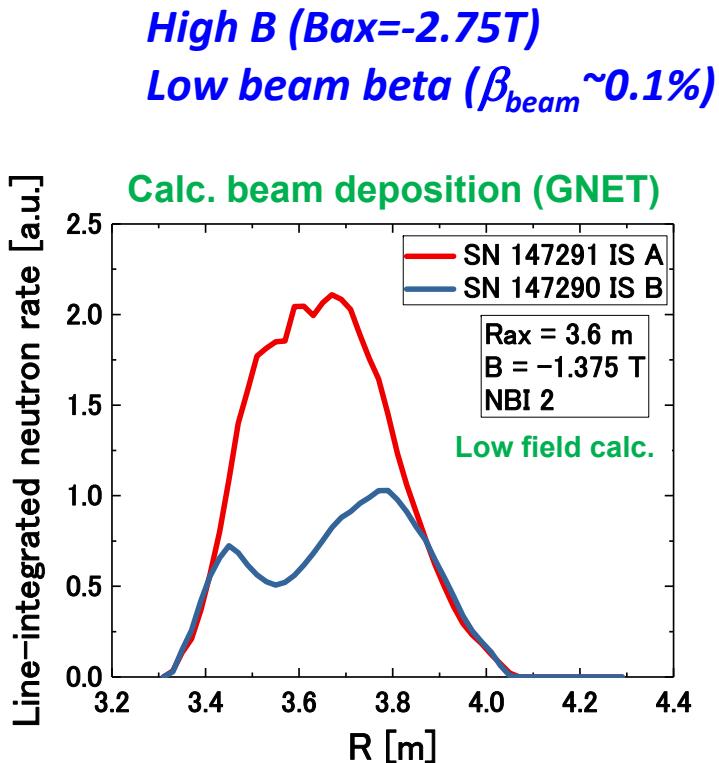
$$V_b < V_A$$

Case 1

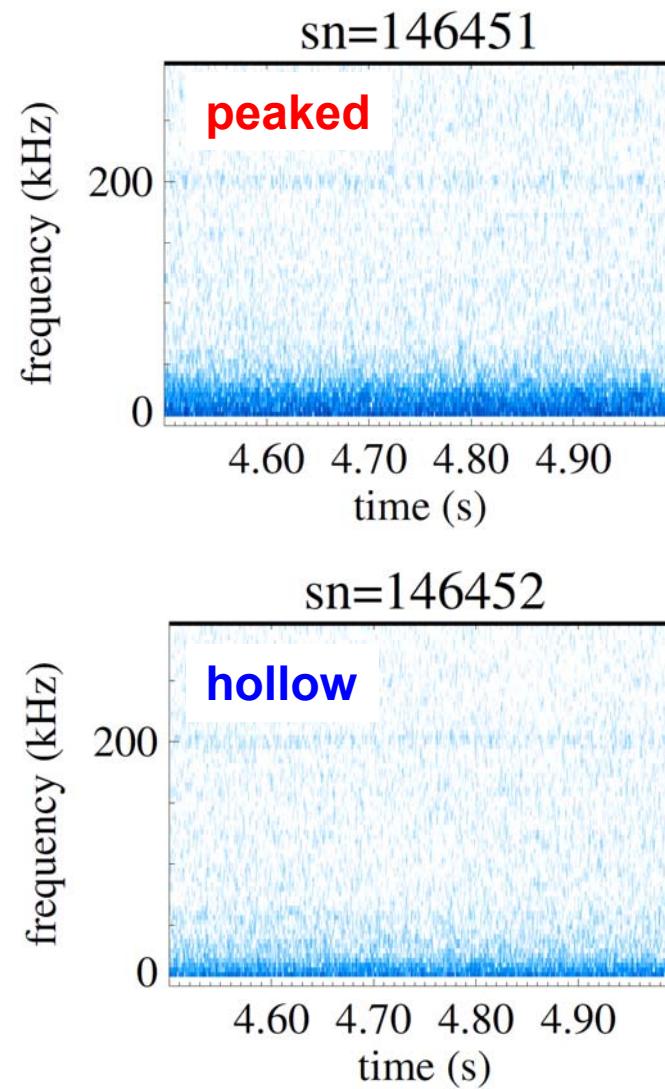
Counter-beam &
Inward-shifted plasma



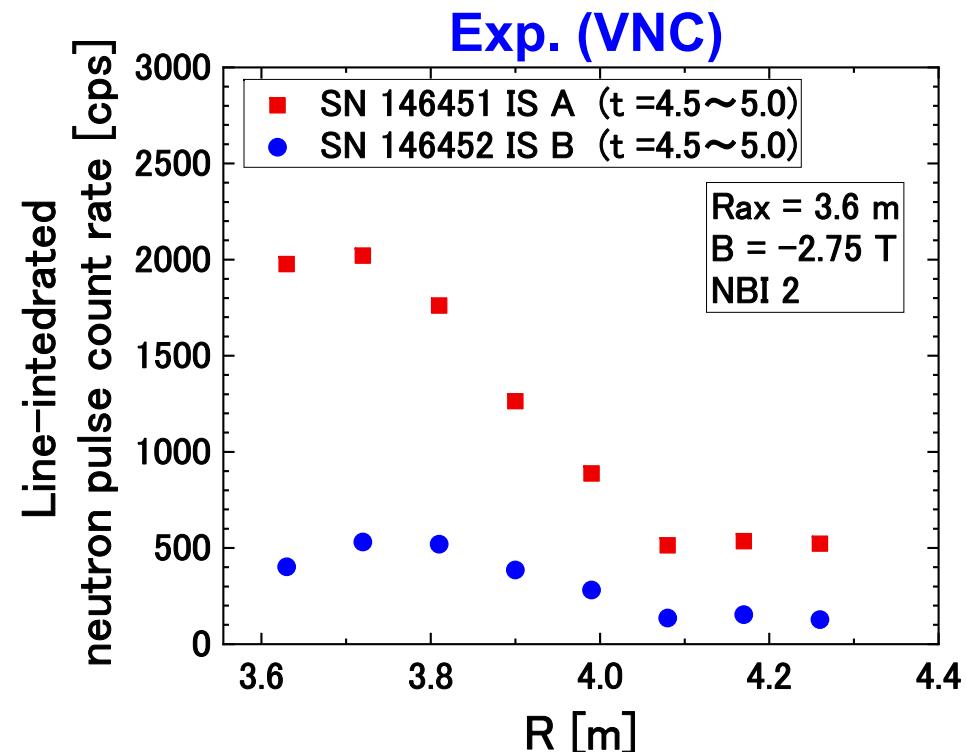
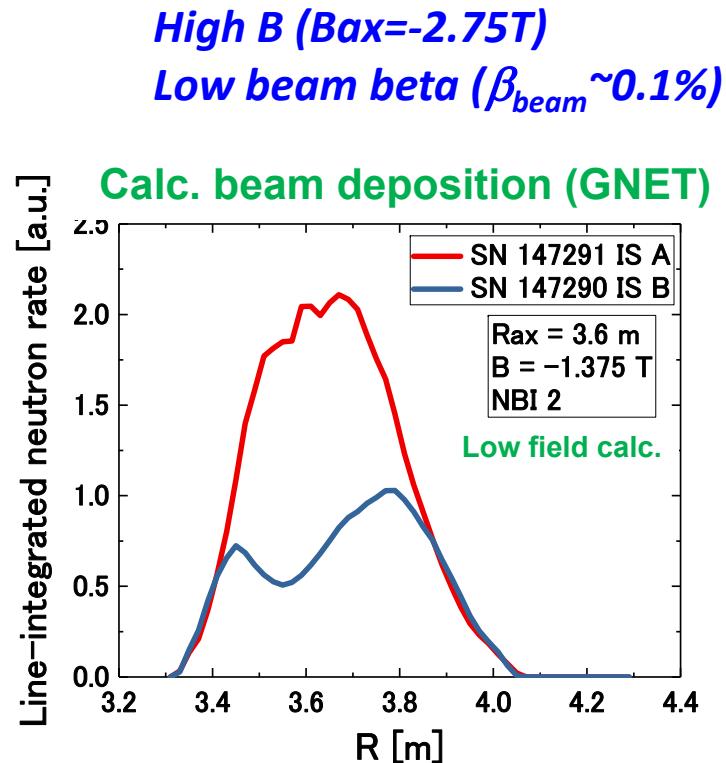
Demonstration of beam deposition control



- No significant AE activities can be seen in both peaked and hollow beam deposition cases



Demonstration of beam deposition control



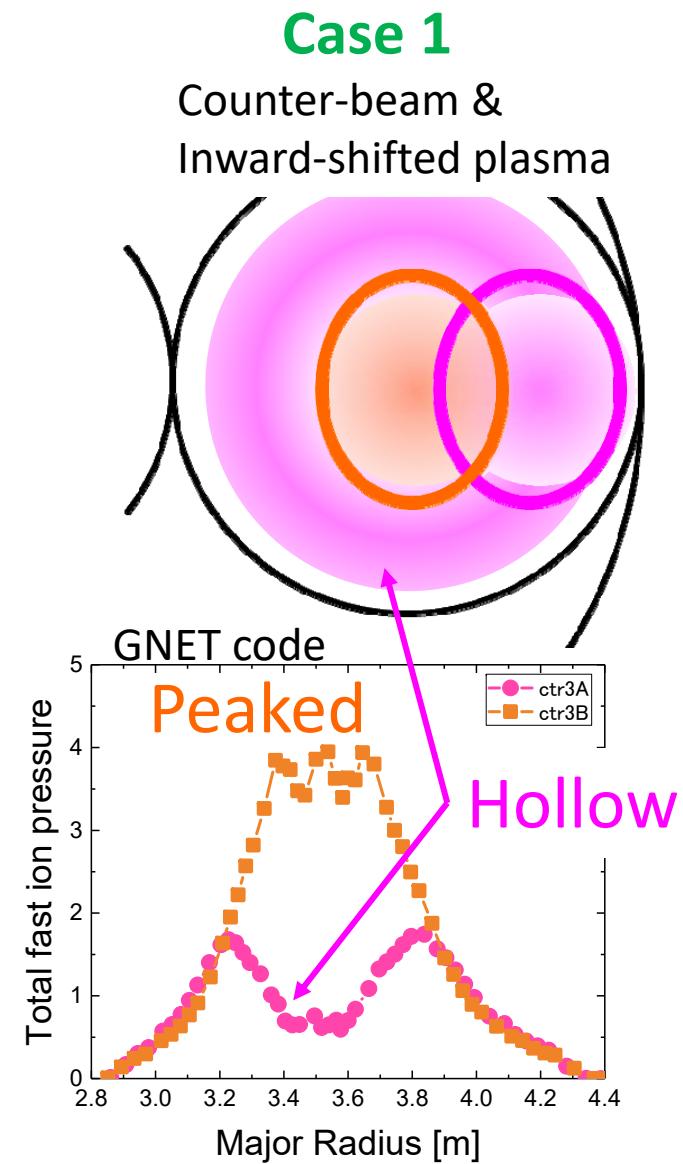
- Neutron emission profiles (**EP profiles**) depend on the beam deposition profile
- =>> Beam deposition control was demonstrated

Demonstration of beam deposition control

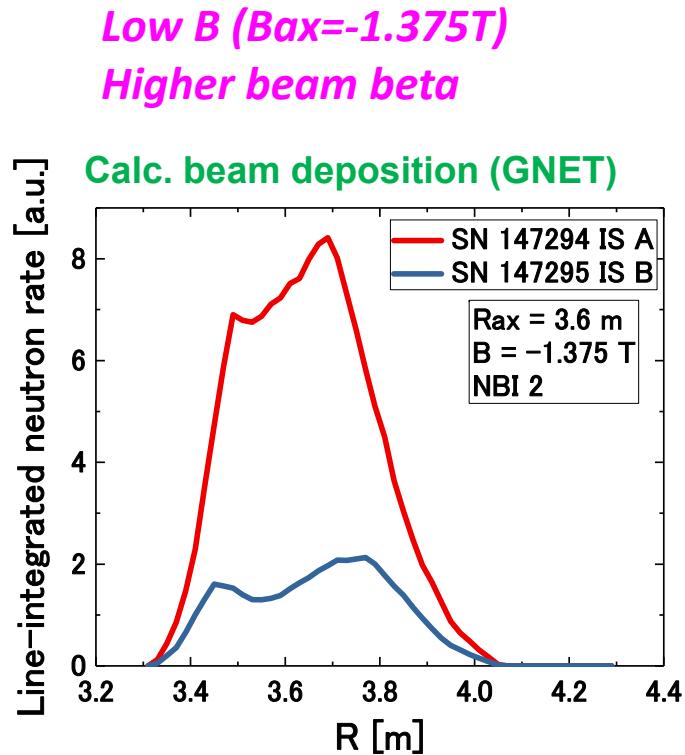
Magnetic field dependence

*Low B ($B_{ax}=-1.375T$)
higher beam beta*

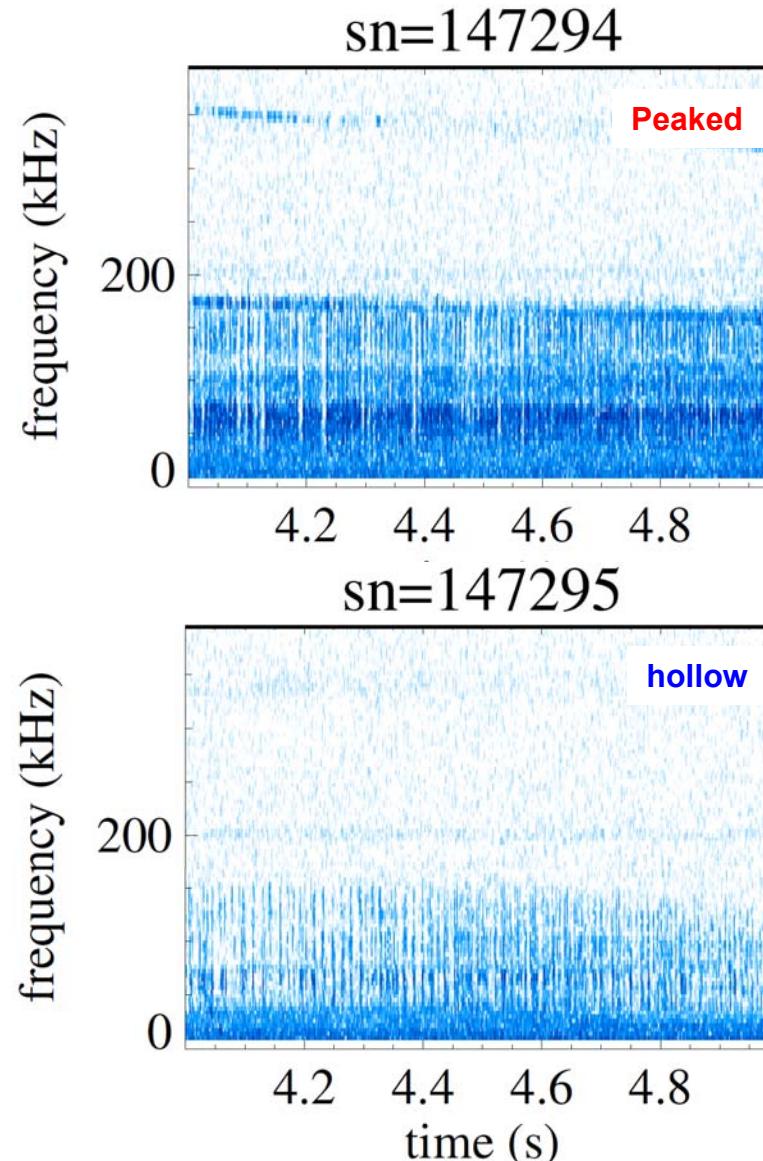
$$V_b > V_A$$



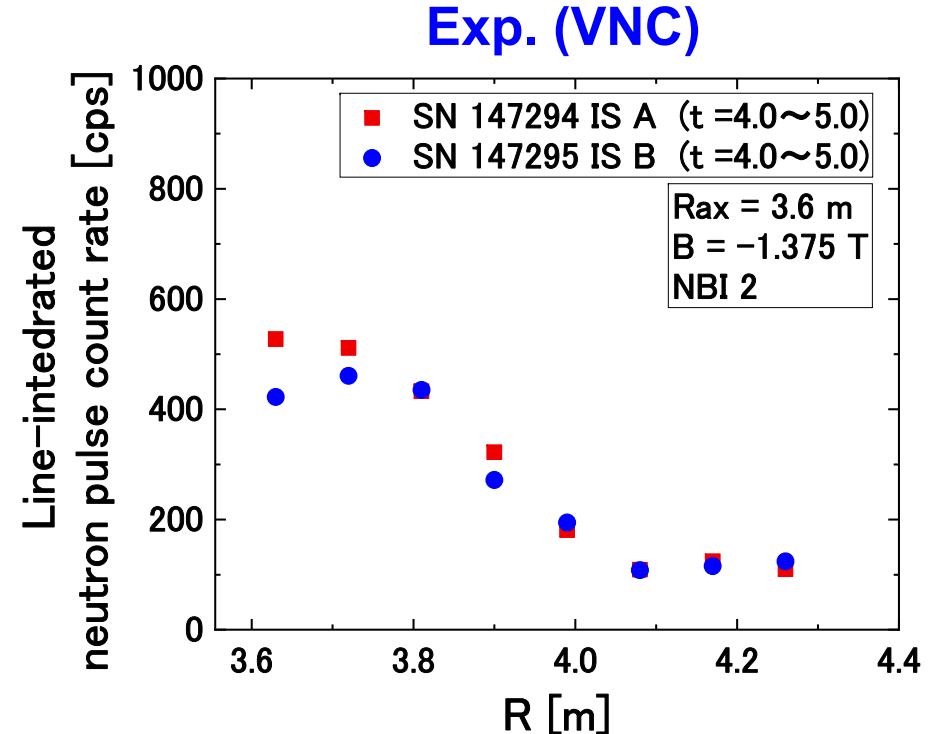
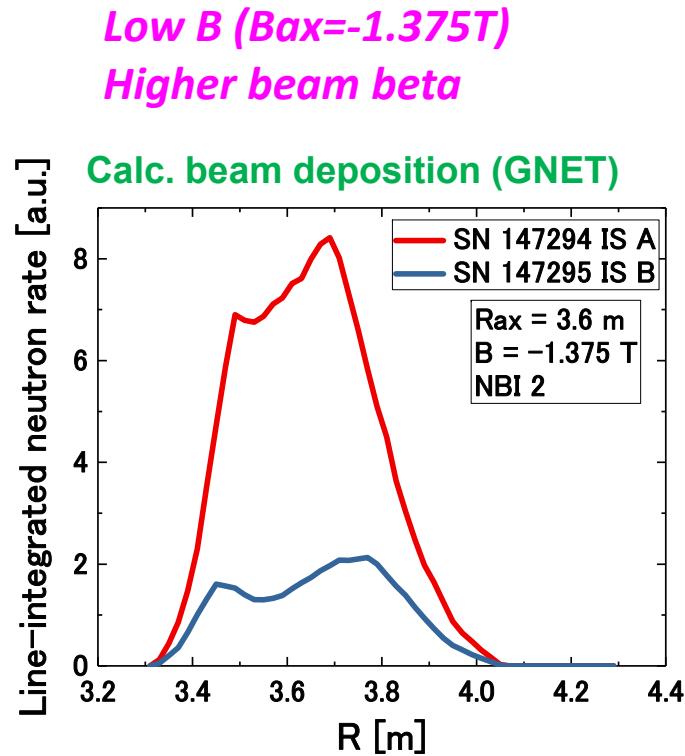
AE activities depends on beam deposition profile



- Many MHD activities in AE frequency range can be seen in both cases
- MHD activities are stronger in peaked beam deposition case



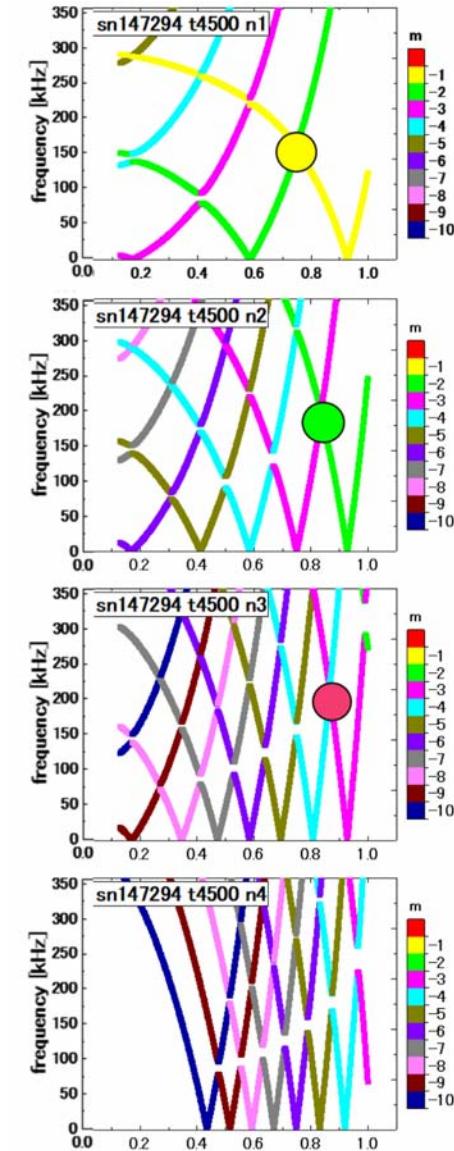
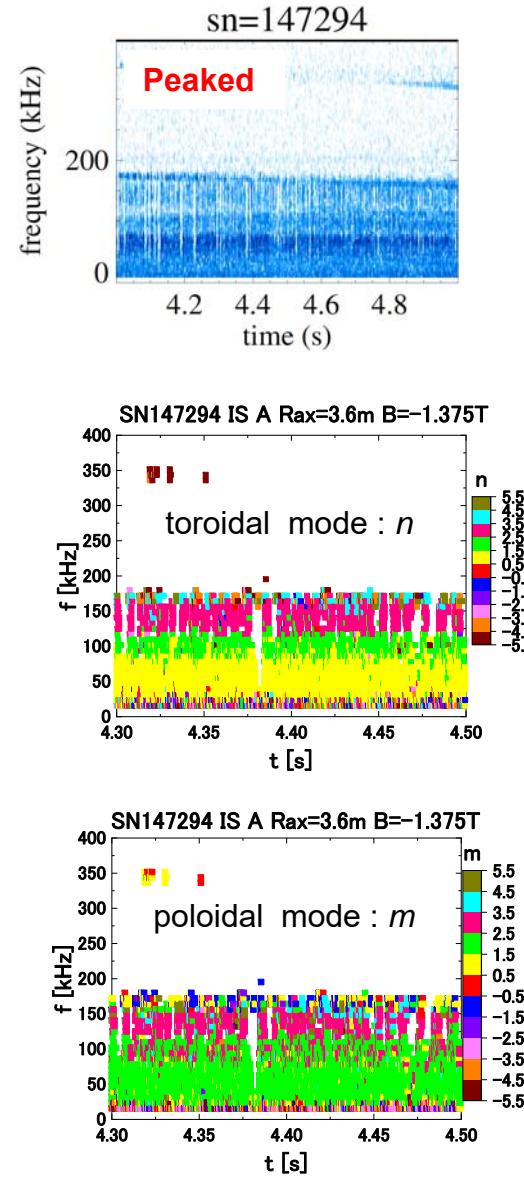
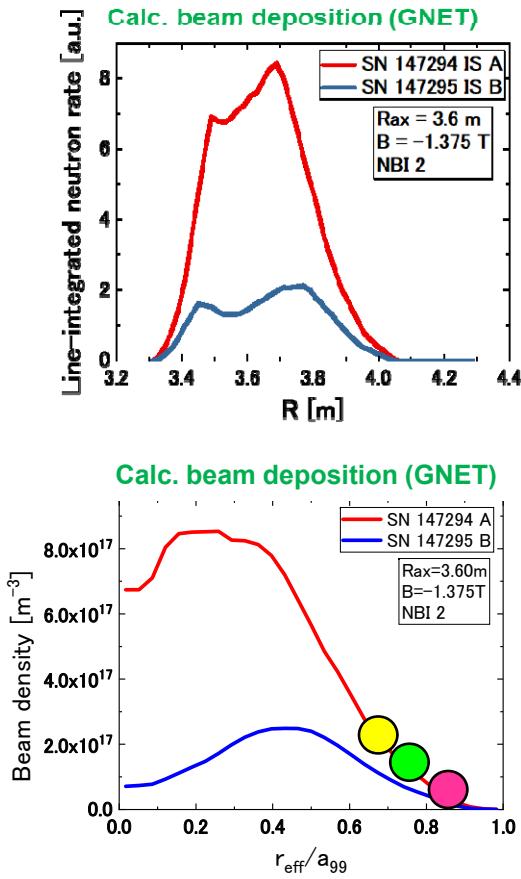
AE activities depends on beam deposition profile



- Similar neutron emission profiles are observed between peaked and hollow beam deposition profile cases.

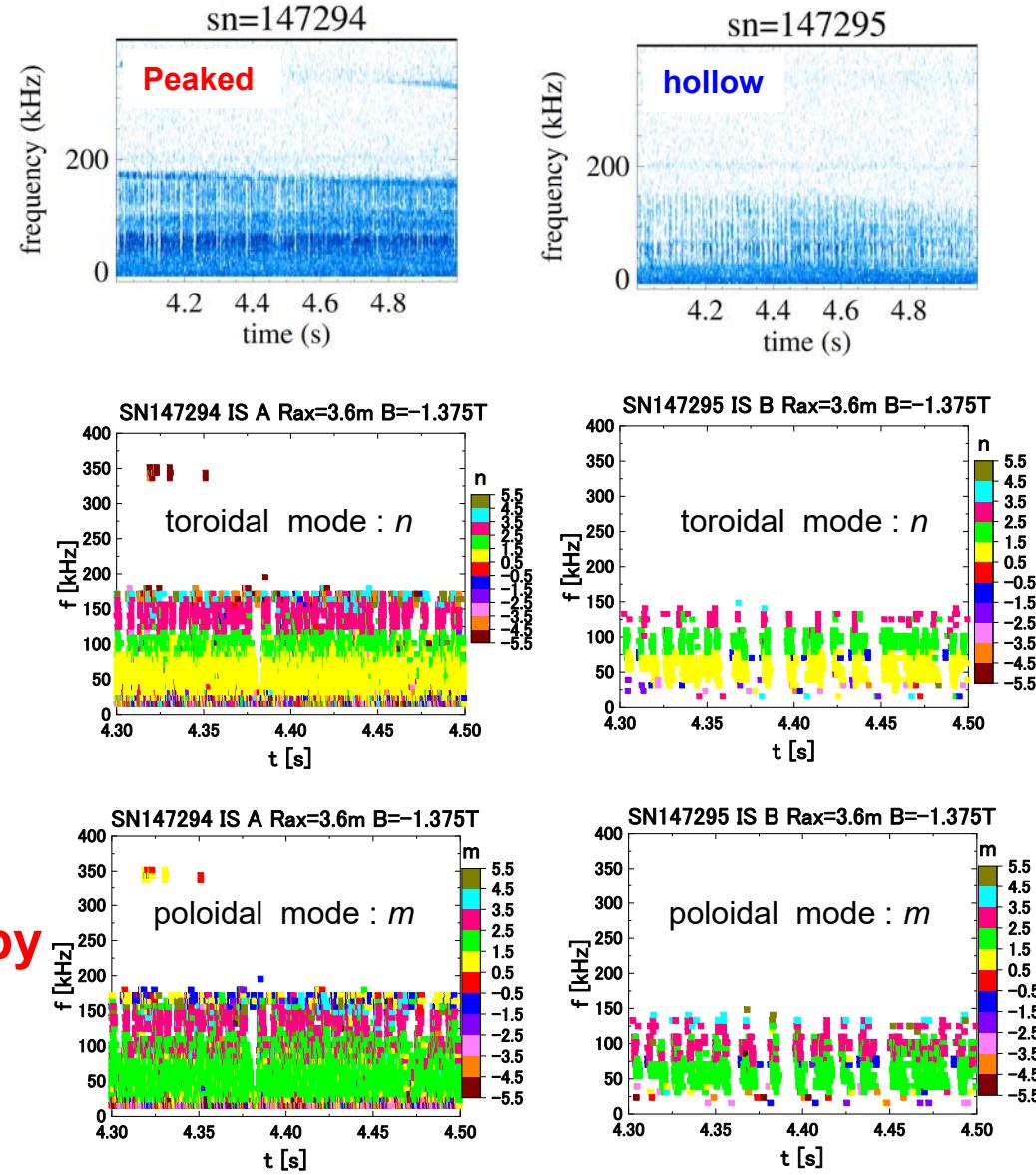
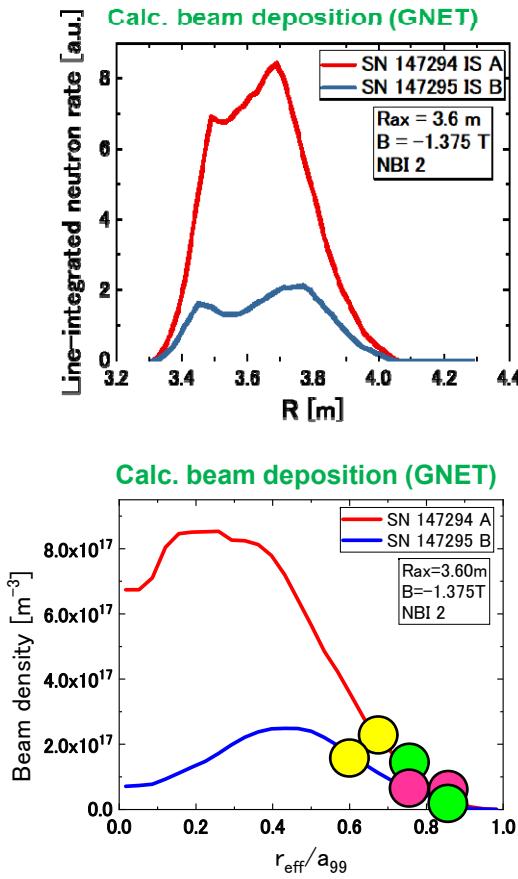
=>> EP profile stiffness with AE activities

AE Mode analyses



- AEs near the edge are excited

AE Mode analyses



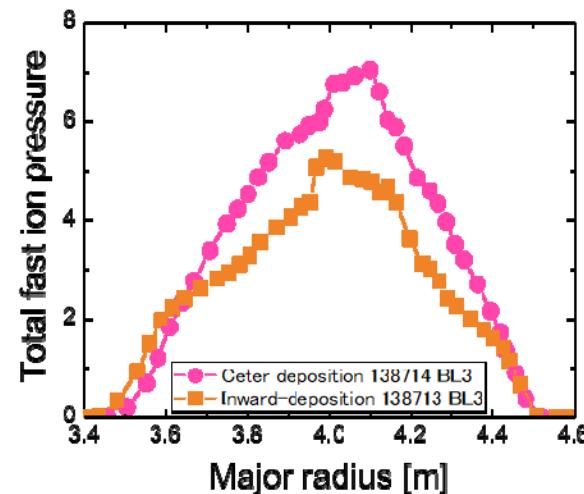
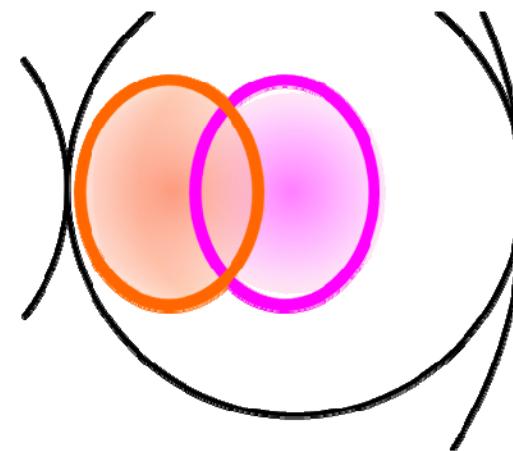
- EP profile is affected by the AE near the edge

EP confinement with beam deposition control

Density dependence

*Low B ($B_{ax}=-1.375T$)
higher beam beta*

Case 2
Co-beam &
Outward-shifted plasma

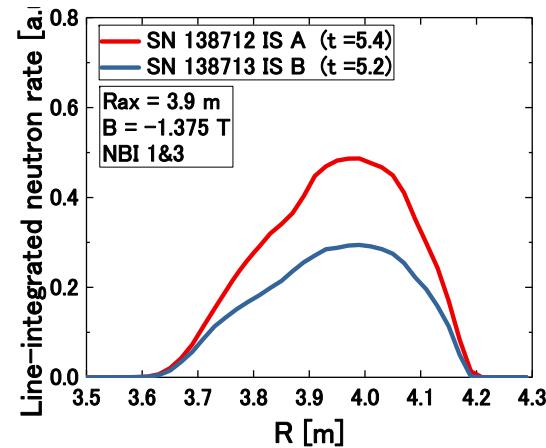


AE activities depend on beam deposition profile

$$n_e \sim 0.4 \times 10^{19} \text{ m}^{-3}$$

- Bursting AEs can be seen in both cases
- Different burst intervals and different frequency range

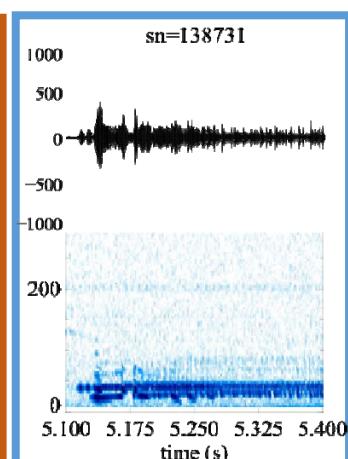
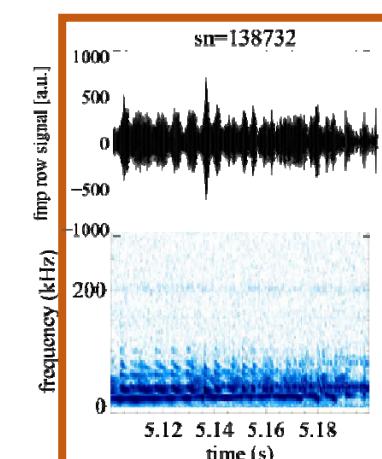
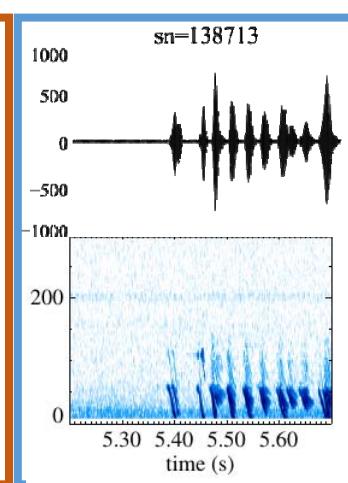
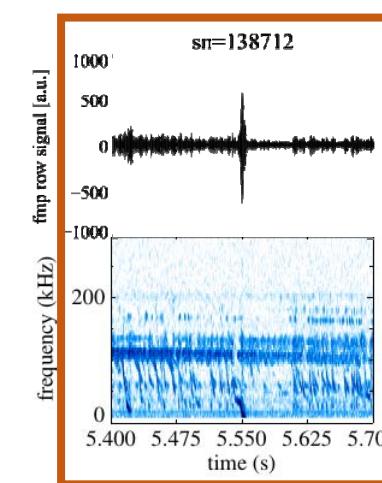
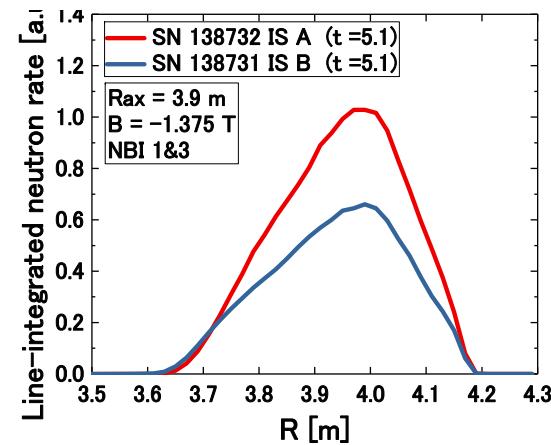
Calc. beam deposition (GNET)



$$n_e \sim 1.4 \times 10^{19} \text{ m}^{-3}$$

- AE activities with larger amplitude and wider frequency range was observed with peaked beam deposition condition

Calc. beam deposition (GNET)



EP profile with beam deposition control

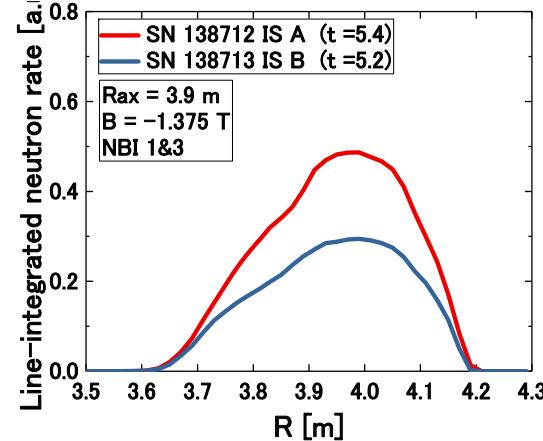
Low B ($B_{ax}=-1.375T$)

Higher beam beta

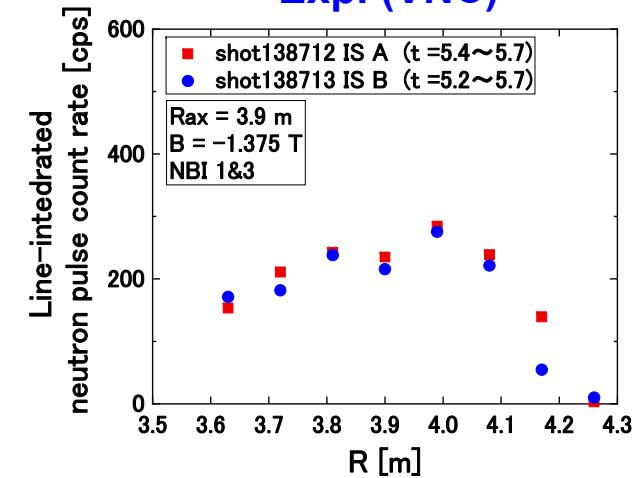
$$n_e \sim 0.4 \times 10^{19} \text{ m}^{-3}$$

- Neutron emission profiles are almost identical with different beam deposition conditions
=> EP profile stiffness

Calc. beam deposition (GNET)



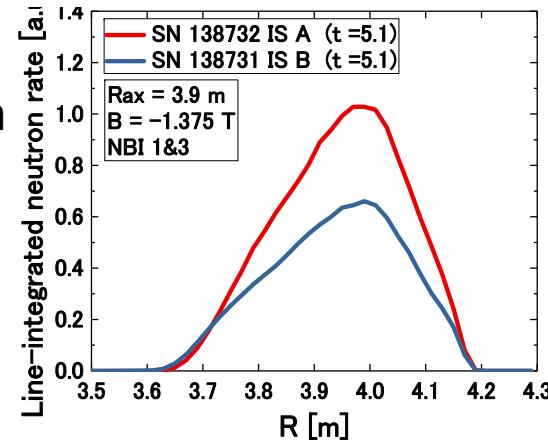
Exp. (VNC)



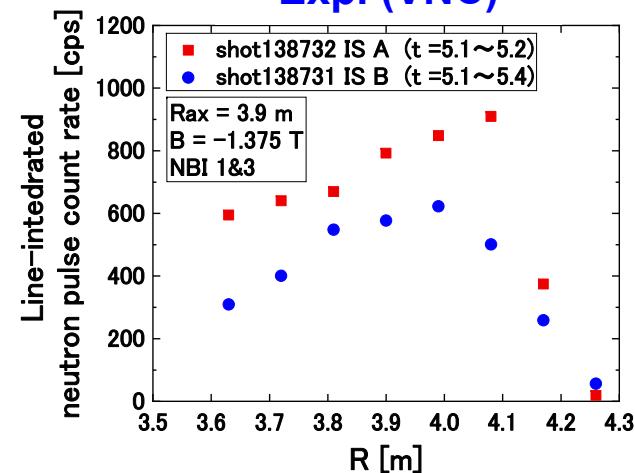
$$n_e \sim 1.4 \times 10^{19} \text{ m}^{-3}$$

- Different neutron emission profiles are observed in the higher density regime
=> EP profile depends on the beam deposition profile

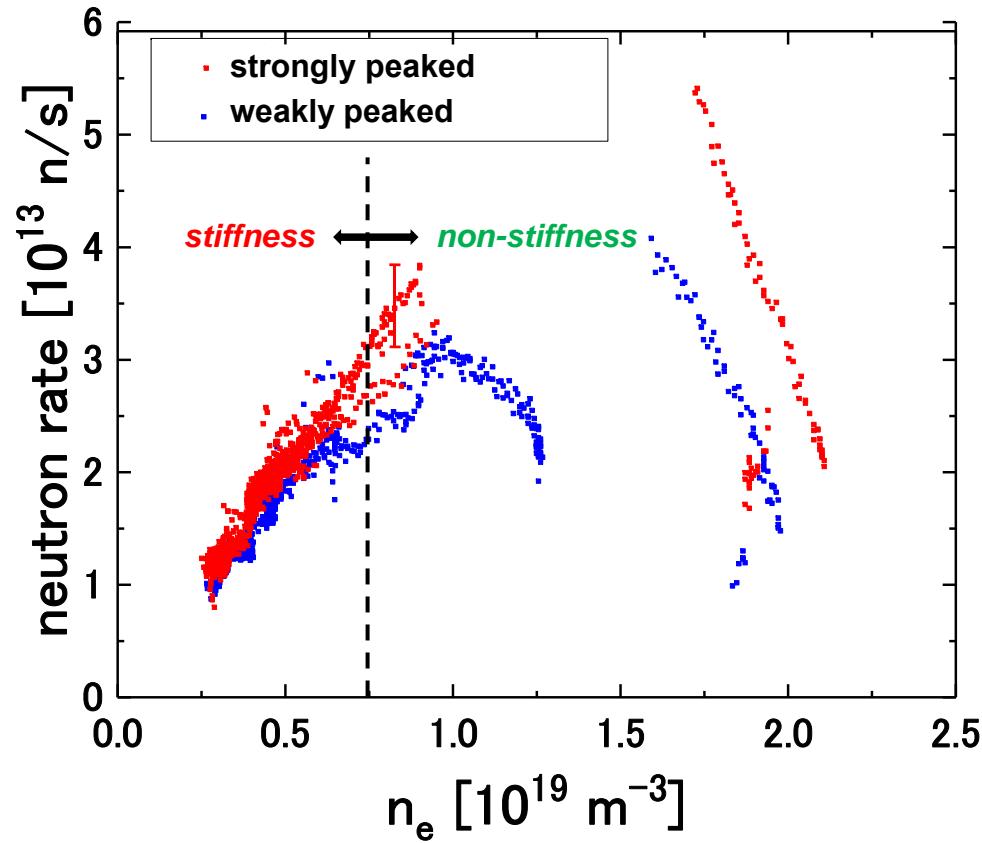
Calc. beam deposition (GNET)



Exp. (VNC)



Density dependence of neutron emission rate



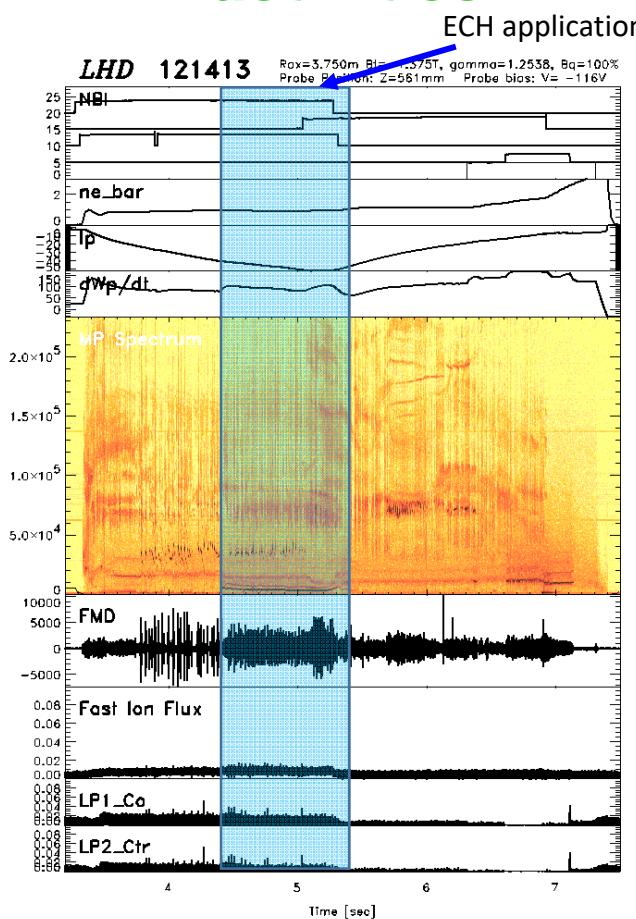
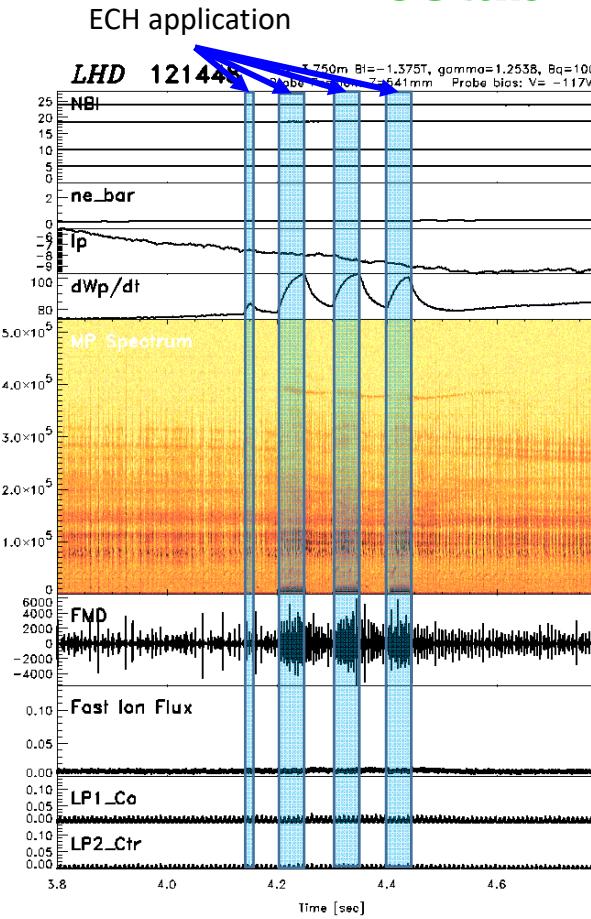
- Neutron rate does not depend on the beam deposition profile in low density regime
=> EP profile stiffness
- Difference in neutron rate can be seen in higher density regime
=> **Density dependence of EP profile stiffness was identified**

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A variety of AE responses to ECH application

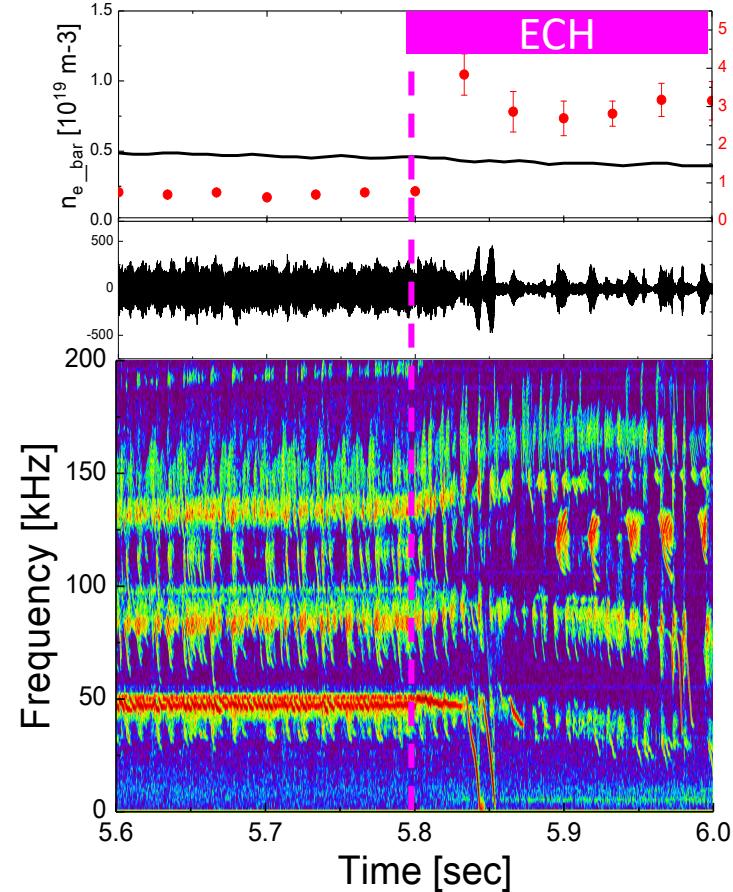
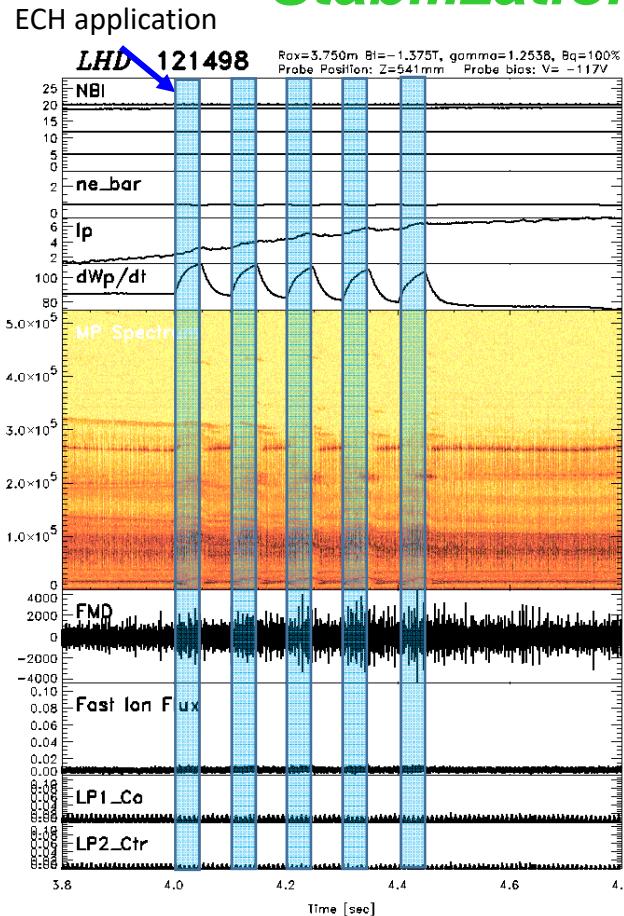
Destabilizations of MHD activities



- ECH application destabilizes MHD activities in low frequency and AE frequency ranges in some conditions

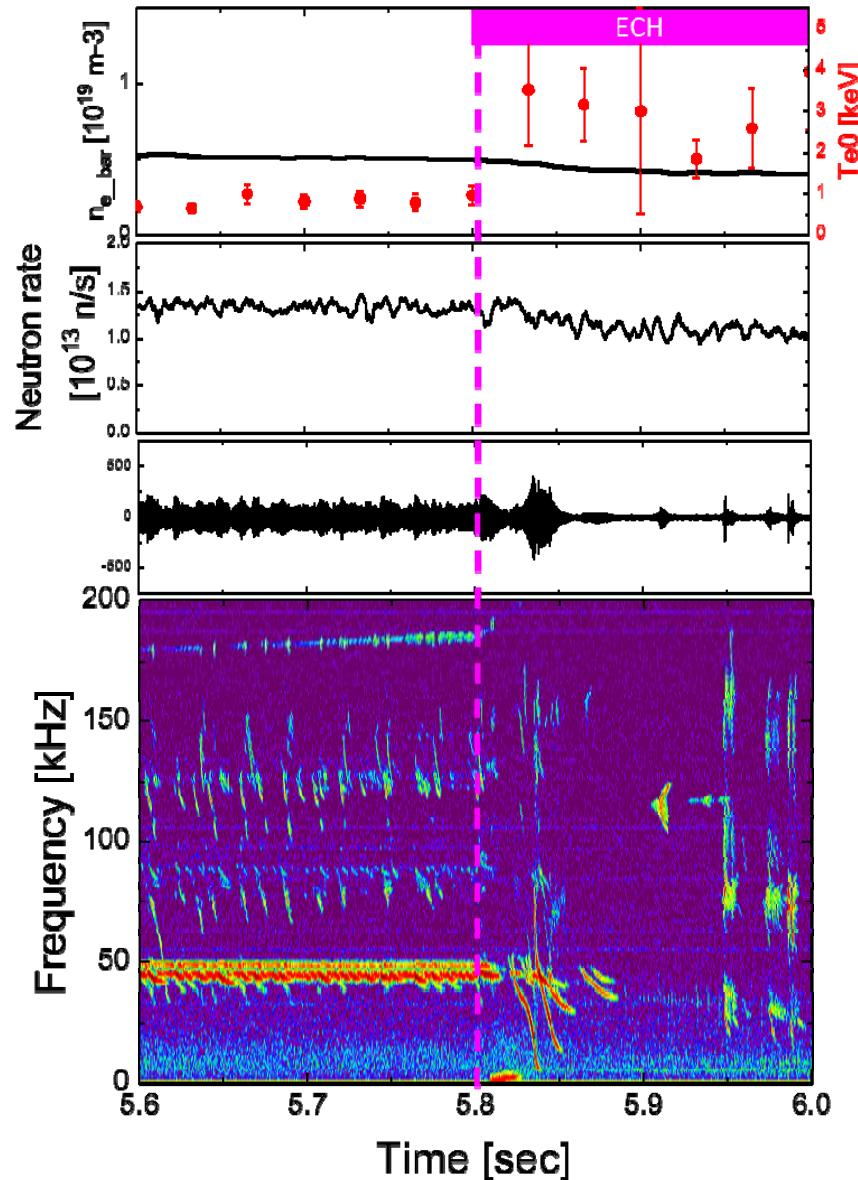
A variety of AE responses to ECH application

Stabilizations of MHD activities



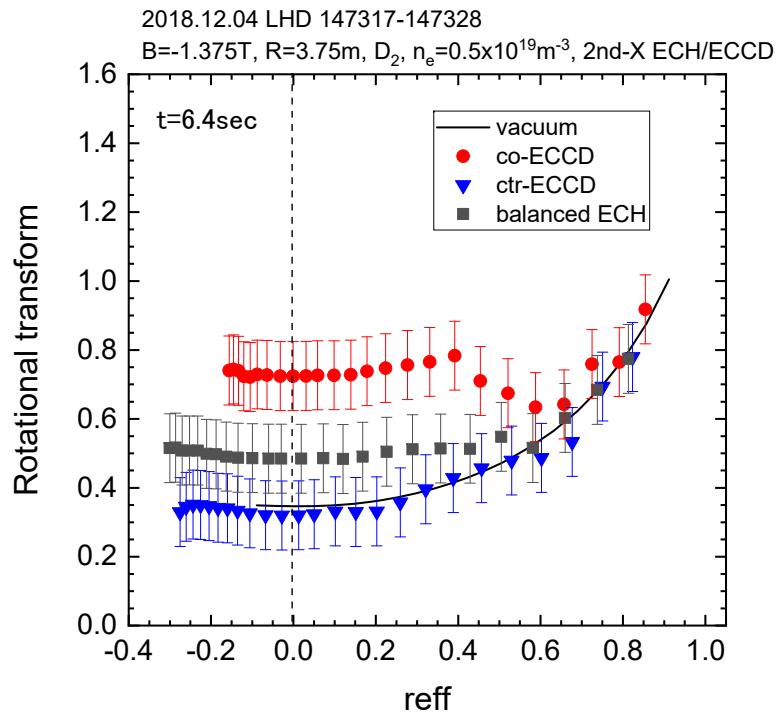
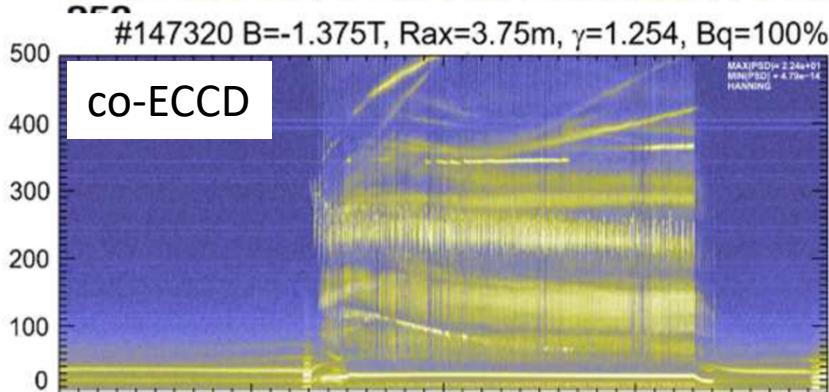
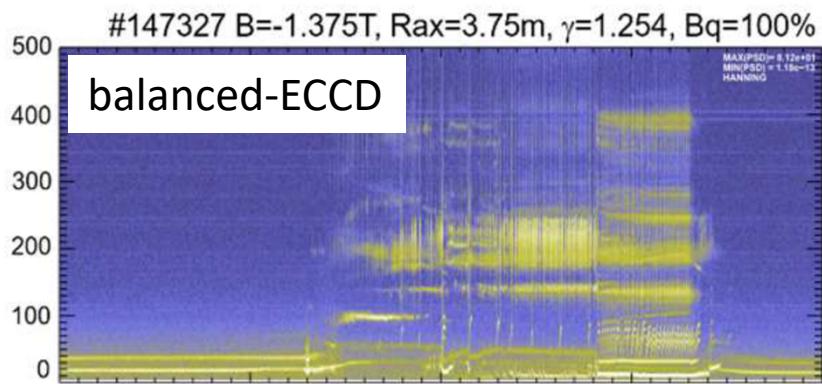
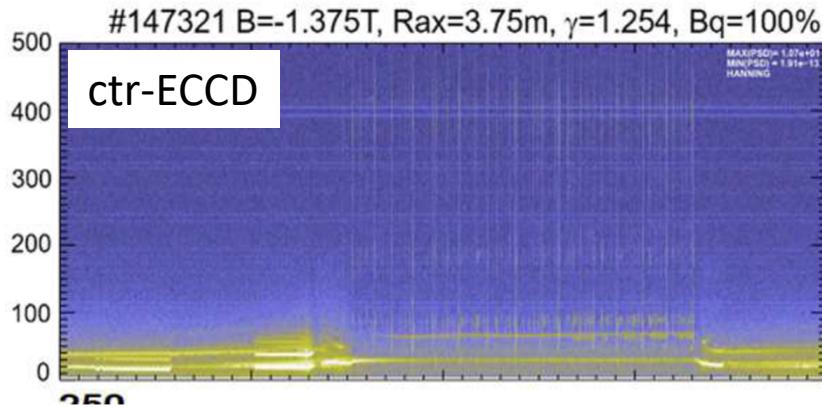
- ECH application stabilizes MHD activities in AE frequency ranges in some conditions

Effect of ECH application to EP confinement



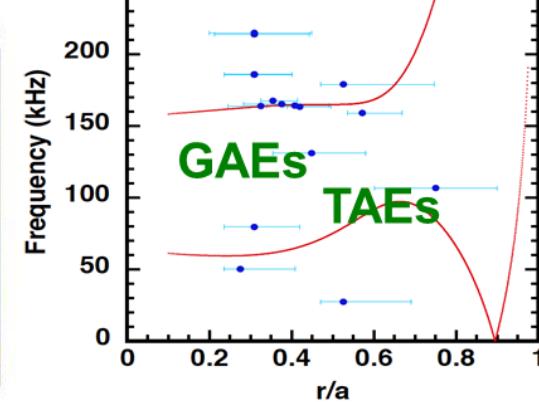
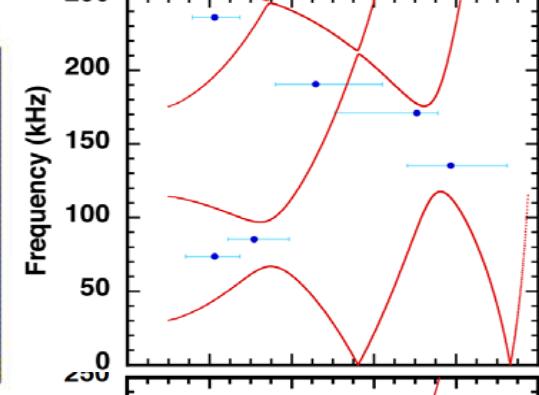
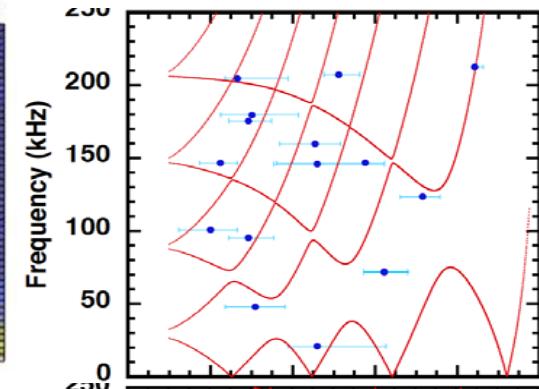
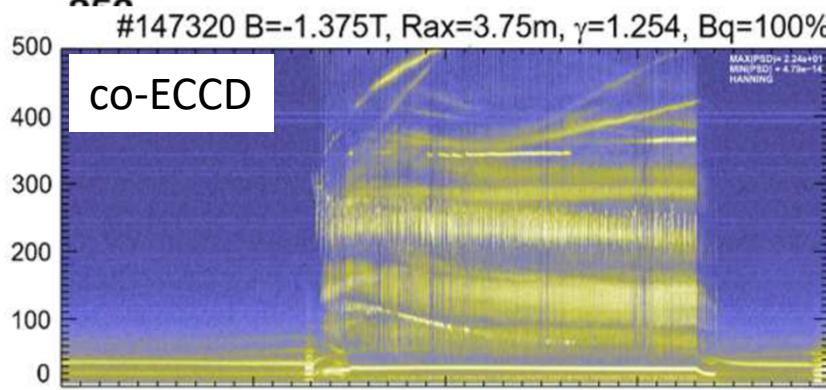
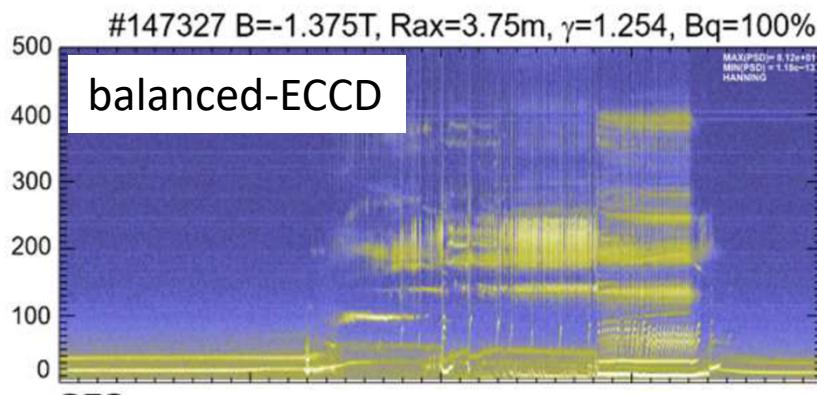
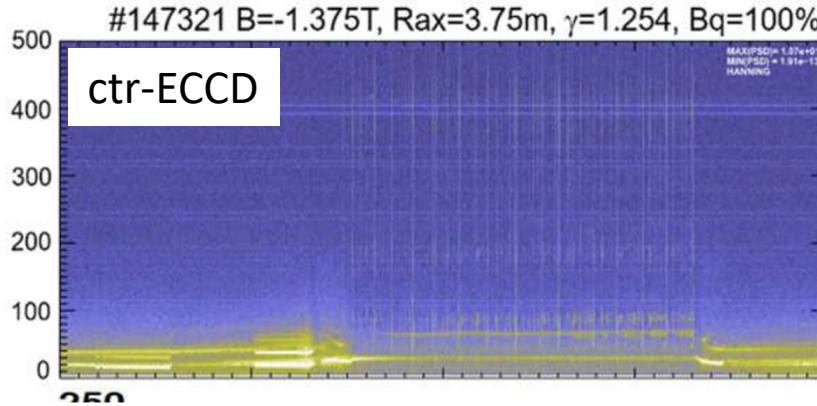
- Stabilization of AE activities was observed when ECH was applied
- T_{e0} increases clearly with ECH application
- However, no increase of neutron rate was observed.
=> Impact of ECH application on EP confinement is NOT clear, while AE activities are changed.

Clear AE responses to **ECCD** applications



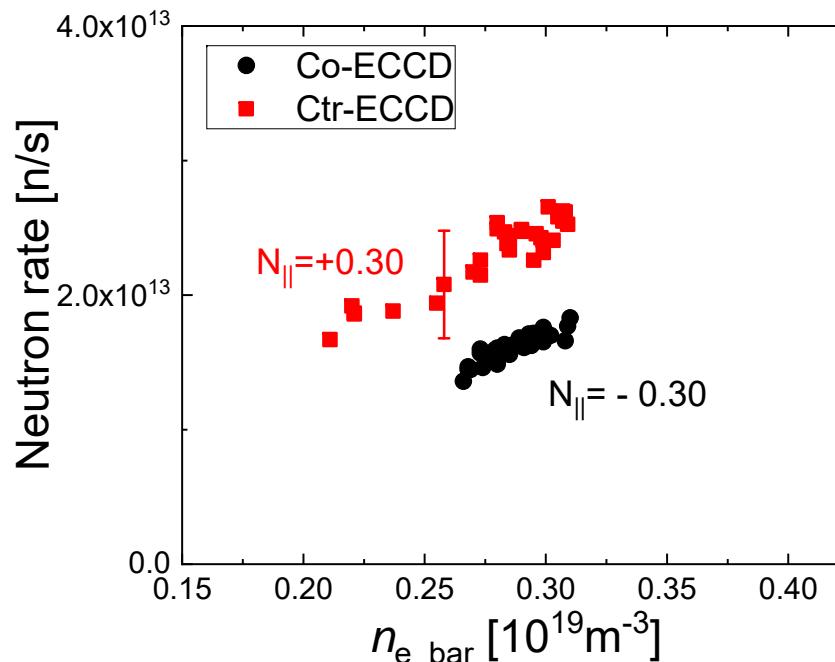
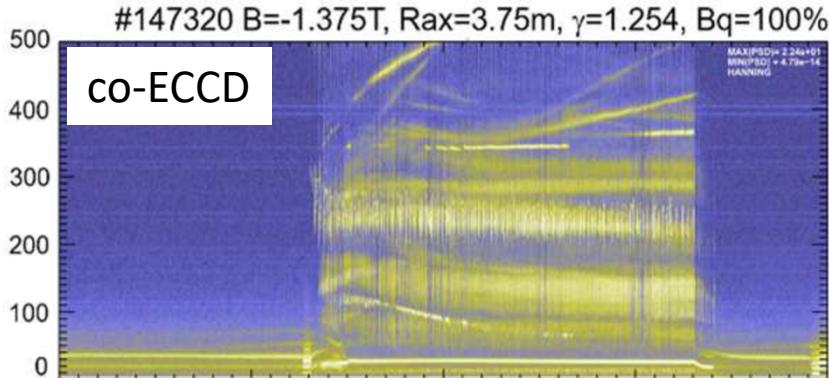
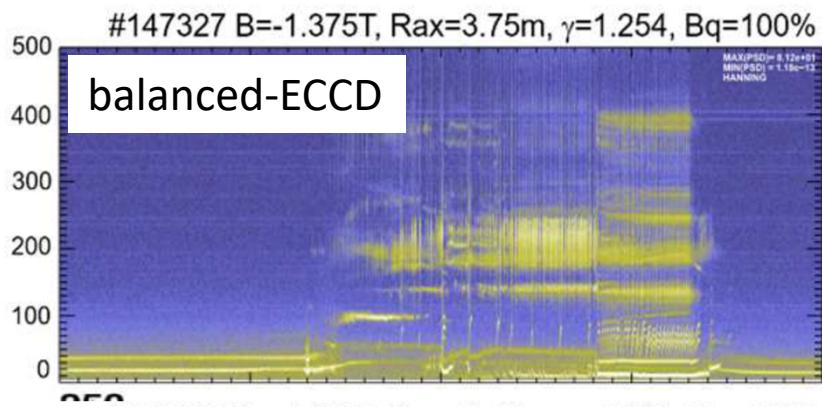
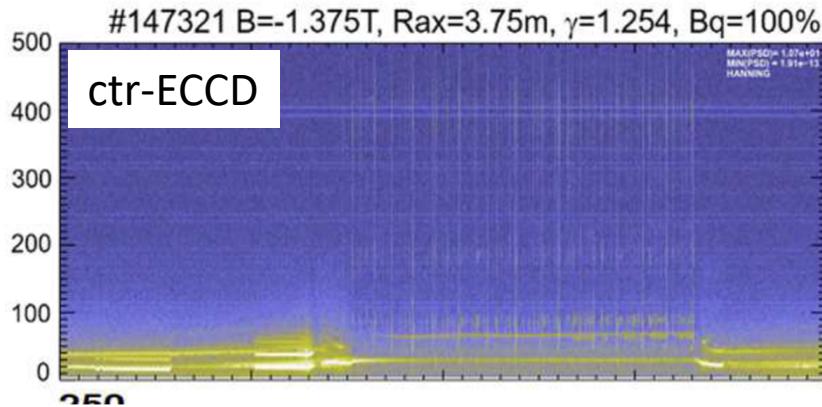
- ECCD can control iota profile
- **AE stabilization with Ctr-ECCD** application was observed
- **AE destabilization with Co-ECCD** was observed

Clear AE responses to **ECCD** applications



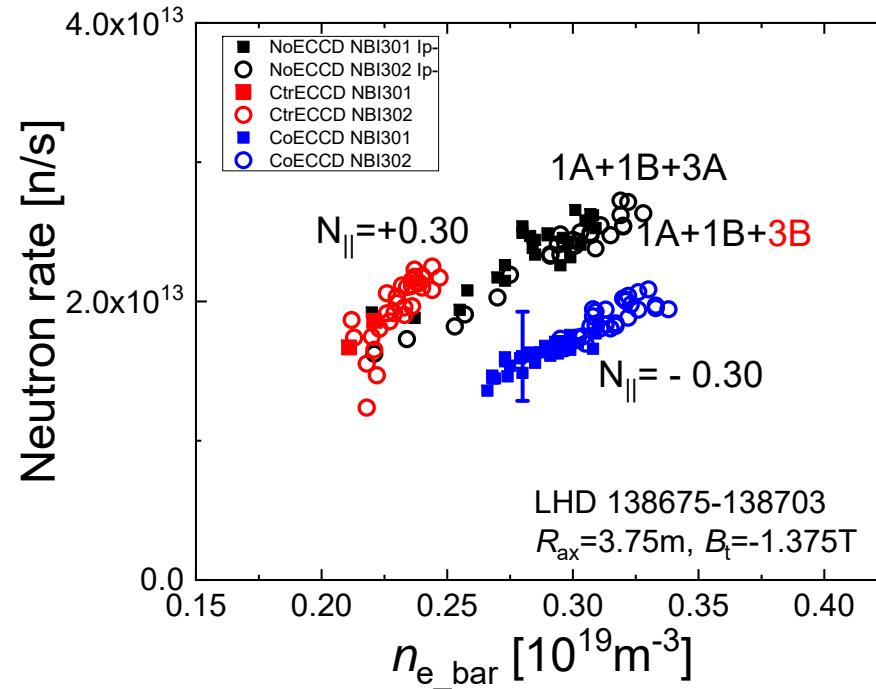
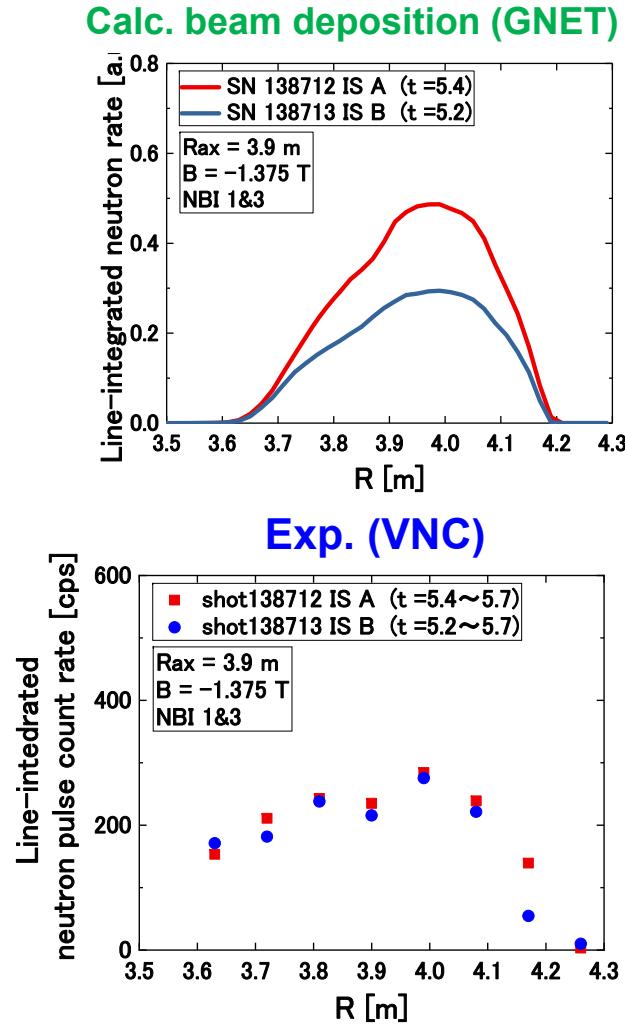
- **Change of Alfvén continuum** contributes the AE stabilization
(Yamamoto, IAEA-FEC, Nagasaki, EPS2019)
- **Increase of continuum damping** is suggested
(P1-1 J. Varela)

Better EP confinement with **ctr-ECCD**



- Neutron emission rate strongly depends on ECCD direction
 - ⇒ ECCD effect on EP confinement
 - ⇒ Ctr-ECCD may enhance EP confinement with suppression of AEs

ECCD may violate EP profile stiffness



- Change of neutron emission rate from EP profile stiffness level was observed with ECCD application.
=> Violation of EP profile stiffness with ECCD application was identified

Summary

EP confinement with AE activities has been investigated in D-D experiment on LHD

■ Control of beam deposition profile

- EP profile stiffness was identified in the low density regime with low magnetic field strength
- Density dependence of EP profile stiffness was observed

■ Impact of ECH and ECCD on AE activities and EP confinement

- A variety of AE responses to ECH application were observed
- Impact of ECH on EP confinement is NOT clear
- AE suppression and EP confinement improvement were identified with ctr-ECCD
- ECCD may violate EP profile stiffness